•			- Ih
	Application No.	Applicant(s)	
A	10/730,998	KEUM ET AL.	
Notice of Allowability	Examiner	Art Unit	
	James J. Leybourne	2881	
The MAILING DATE of this communication appeal claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this apply or other appropriate communication (IGHTS). This application is subject to	plication. If not includ will be mailed in due	ed course. <b>THIS</b>
1. This communication is responsive to			
2. ☑ The allowed claim(s) is/are <u>1-19</u> .			
3. 🔀 The drawings filed on 10 December 2003 are accepted by	the Examiner.		
<ul> <li>4.  Acknowledgment is made of a claim for foreign priority unally a)  All b)  Some* c)  None of the:</li> <li>1.  Certified copies of the priority documents have 2.  Certified copies of the priority documents have 3.  Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)).</li> <li>* Certified copies not received:</li> </ul>	e been received. e been received in Application No		ation from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a reply MENT of this application.	complying with the re	quirements
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which giv			IOTICE OF
<ol> <li>CORRECTED DRAWINGS (as "replacement sheets") mu         <ul> <li>(a) including changes required by the Notice of Draftsper</li> <li>1) hereto or 2) to Paper No./Mail Date</li> <li>(b) including changes required by the attached Examiner Paper No./Mail Date</li> <li>Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in</li> </ul> </li> <li>7. DEPOSIT OF and/or INFORMATION about the deposition of the sheet in the sh</li></ol>	son's Patent Drawing Review (PTO- -· 's Amendment / Comment or in the C 1.84(c)) should be written on the drawi the header according to 37 CFR 1.121(	Office action of ngs in the front (not the	
attached Examiner's comment regarding REQUIREMENT	FOR THE DEPOSIT OF BIOLOGIC	AL MATERIAL.	
Attachment(s) 1.   Notice of References Cited (PTO-892)	5. ☐ Notice of Informal F	Patent Application (PT	O-152)
<ol> <li>Notice of References Cited (PTO-692)</li> <li>Dotice of Draftperson's Patent Drawing Review (PTO-948)</li> </ol>			- ··-/
	Paper No./Mail Da	te	
<ol> <li>Information Disclosure Statements (PTO-1449 or PTO/SB/ Paper No./Mail Date 3/16/04</li> </ol>	08), 7. Examiner's Amend	menvComment	
4.   Examiner's Comment Regarding Requirement for Deposit	8. X Examiner's Statement	ent of Reasons for All	owance
of Biological Material	9. 🗌 Other		

Art Unit: 2881

## **DETAILED ACTION**

## Allowable Subject Matter

- 1. Claims 1-19 are allowed.
- 2. The following is an examiner's statement of reasons for allowance:

Regarding independent claims 1 and 11, the prior art fails to disclose or make obvious a polarity exchanger or an ion implanter that comprises a polarity exchanger wherein said polarity exchanger comprises a stripping canal, a gas supply unit with a gas circulation unit for providing a stripping gas into the stripping canal a flow meter for measuring a flow rate of the stripping, an ammeter for measuring a driving current applied to the gas circulation unit and a monitoring unit for generating a control signal to control a process for changing the polarity of the ion beam in accordance with a measured flow rate of the stripping gas and a measured driving current.

Claims 2-10 and 12-19 are allowed by virtue of their dependency on claims 1 and 11 respectively.

The main feature that separates the apparatus apart from prior art is the use of a flow meter to measure the gas flow rate and a current meter to measure the driving current of the circulation unit. The prior art has used a fixed pumping speed and controlled gas flow in the stripper by using a fixes orifice and controlling the pressure of the gas feeding the orifice and a vacuum sensor to monitor the pressure in the stripping chamber.

Application/Control Number: 10/730,998 Page 3

Art Unit: 2881

3. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance"

## Relevant Prior Art

3. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Kwon (USPN 6639230) uses a current sensor for checking for abnormal conditions and a controller to turn off a turbo pump.

Mack et al. (USPN 5959305) use a mass flow controller (MFC) to regulate gas flow to a vacuum chamber. Gas may be supplied to arc chamber at any suitable flow rate.

Choi et al. (USPN 6462331) uses a current detector to detect a current flowing to a turbo pump and a controller stops the pump and the ion implantation apparatus if the current is out of a specified range.

## Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to James J. Leybourne whose telephone

Application/Control Number: 10/730,998 Page 4

Art Unit: 2881

number is (571) 272-2478. The examiner can normally be reached on M-F 9:00-6:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John R Lee can be reached on (571) 272-2477. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

October 19, 2004

JJL

SUPERVISORY PATENT EXAMINER